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## APPLICANTS

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 \*\* CONTINUING DATA \*\*\*\*\* *None* *TL*

 \*\* FOREIGN APPLICATIONS \*\*\*\*\* *Yes* *TL*

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	4	20	4
Examiner's Signature <i>[Signature]</i> Initials				

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## TITLE

Semiconductor device and method for manufacturing partial SOI substrates

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